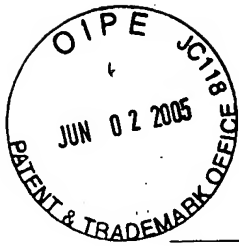


06-06-05

JC02 Rec'd PCT/PTA 02 JUN 2005

PCT



Docket No.: 63004(70868)
(PATENT)

#3

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Junichiro Nakayama et al.

Application No.: 10/526,855

Confirmation: Not Yet Assigned

Filed: March 3, 2005

Art Unit: Not Yet Assigned

For: LASER PROCESSING METHOD AND
LASER PROCESSING APPARATUS

Examiner: Not Yet Assigned

INFORMATION DISCLOSURE STATEMENT (IDS)

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is filed within three months of the U.S. filing date (37 CFR 1.97(b)(1)).

A summary/abstract translation of the non-English language references is enclosed and a complete translation of reference BA (see WO 97/45827).

The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 04-1105, under Order No. 63004(70868).

Dated: June 2, 2005

Respectfully submitted

By 

George W. Neuner

Registration No.: 26,964

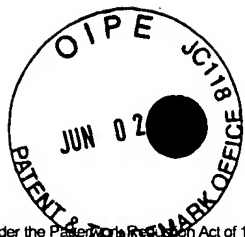
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PTO/SB/08a/b (08-03)

Approved for use through 07/31/2006, OMB 0651-0031

U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

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Substitute for form 1449A/B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Complete if Known	
				Application Number	10/526,855
				Filing Date	March 3, 2005
				First Named Inventor	Junichiro Nakayama
				Art Unit	Not Yet Assigned
				Examiner Name	Not Yet Assigned
Sheet	1	of	1	Attorney Docket Number	63004(70868)

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
	AA	6,117,752	9/12/2000	Suzuki	

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				
	BA	JP-2000-505241	4/25/2000			
	BB	WO 97/45827	12/4/1997			
	BC	JP-62-194613	8/27/1987			
	BD	JP-59-025215	2/9/1984			
	BE	JP-2003-257860	9/12/2003			

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NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	CA	Sposili et al., "Sequential lateral solidification of thin silicon films on SiO ₂ ", Applied Physics Letters, Vol. 69, No. 19, Nov. 4, 1996, pp. 2864-2866.	
	CB	Lee et al., "Ultra-large lateral grain growth by double laser recrystallization of a -Si films", Applied Physics A, Vol. 73, 2001, pp. 317-322.	
	CC	Jyumonji et al., "Double-Pulse Method for Enlarging Lateral Grain Growth of Excimer Laser Annealed Poly-Si Thin Films", NEC Res. & Develop, Vol. 42, No. 3, Jul. 2001, pp. 272-276.	

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Examiner Signature		Date Considered	
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Application No. (if known): 10/526,855

Attorney Docket No.: 63004(70868)

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IDS (Citation) by Applicant
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